

Whyte Hirschboeck Dudek S.C.

FAX COVER SHEET

January 10, 2006

TO:

Examiner Pham

COMPANY:

USPTO

FAX NO.:

571-273-1696

FROM:

Kristine M. Strodthoff

PAGES:

(356)

19 (including cover page)

CLIENT-MATTER:

firm-firm

JOB NO.: 4312

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Message:

In re Application of : Weimer, Ronald A.
Serial No. : 09/941,827
Filing Date : August 29, 2001
For : Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
Examiner : HUYNH, Yennhu B.
Group Art Unit : 2813
Confirmation No. : 7551

Per your request attached is the IDS dated September 4, 2003. Please call me if you have any questions at 414-978-5531.

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PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Weimer, Ronald A.
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COPY**CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10**

I hereby certify that, on the date shown below, this correspondence is being:

Mailing

- ☒ deposited with the United States Postal Service in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231
37 CFR 1.8(a) 37 CFR 1.10
☐ with sufficient postage as first class mail ☒ As "Express Mail Post Office to Addressee" Mailing Label No. EV 048318230 US

Transmission

- ☐ transmitted by facsimile to Fax No _____ addressed to Examiner _____ at the U.S. Patent and Trademark Office.

Date: 12-3-02

Antony J. Juty

Assistant Commissioner for Patents
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with Applicant's duty of disclosure as set forth in 37 C.F.R. §1.56, listed on the attached equivalent to Form PTO-1449 are those patents and other publications known to Applicant which may be considered material to the patentability of the claims of the above-identified application.

Applicant respectfully requests that the listed documents be considered by the Examiner, that these references be made of record in the present application, and that an initialed copy of the Form PTO-1449 be returned to the undersigned in accordance with MPEP 609.

MKE/808000.1

USSN 09/941,827

Supplemental Information Disclosure Statement

No fee is due for consideration of these items because this statement is submitted prior to the issuance of an Office Action on the merits.

Respectfully submitted,

Dated: December 3, 2002

Kristine M. Strodthoff, Reg. No. 34,259
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(414) 273-2100
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Patent

Attorney Docket No. MTI-31532

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|---|-------------------|------------------|
| U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE Washington, D.C. 20231 INFORMATION DISCLOSURE STATEMENT BY APPLICANT | ATTY. DOCKET NO. | Serial No. |
| | MTI-31532 | 09/941,827 |
| | Applicant | Confirmation No. |
| | Weimer, Ronald A. | 7551 |
| | Filing Date | Group Art Unit |
| | August 29, 2001 | 2812 |

U.S. PATENT DOCUMENTS

| | Patent Number | Issue Date | Patentee | U.S. Class | Sub-Class | Filing Date |
|--|---------------|------------|---------------|------------|-----------|-------------|
| | 6,475,883 | 11/05/02 | Powell et al. | 438 | 486 | 07/03/01 |
| | 6,410,968 | 06/25/02 | Powell et al. | 257 | 412 | 08/31/00 |
| | 6,362,086 | 03/26/02 | Weimer et al. | 438 | 591 | 09/15/99 |
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FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

| Examiner Initial | Document Number | Publication Date | Country | Int'l Class | Sub-Class | Translation (Yes/No) |
|------------------|-----------------|------------------|---------|-------------|-----------|----------------------|
| | B1 | | | | | |

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

| Examiner Initial | Non-Patent Document |
|------------------|---------------------|
| | C1 |

| | |
|---|-----------------|
| Examiner Initials | Date Considered |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |

MKE/808015.1

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THE STAMP OF THE U.S. PATENT & TRADEMARK OFFICE HEREON
DENOTES RECEIPT ON THE DATE STAMPED OF:

| | |
|-----------------------|--|
| In re Application of: | Weimer, Ronald A. |
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| Examiner: | Huynh, Yennhu B. |
| Attorney Docket No.: | MTI-31532 |

Enclosures: Response, copy of previously submitted IDS and Form 1449/PTO.
and return postcard.

Date: September 4, 2003
Express Mail No. EV 326236245 US
PRR/KXS